

Electronic Patent Application Fee Transmittal

Application Number:	10721225			
Filing Date:	26-Nov-2003			
Title of Invention:	Method and structures for increasing the structure density and the storage capacitance in a semiconductor wafer			
First Named Inventor/Applicant Name:	Joern Luetzen			
Filer:	Ira Stuart Matsil			
Attorney Docket Number:	INF 2004 SP 00115 US			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1202	9	50	450
Independent claims in excess of 3	1201	1	210	210
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	120	120
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1590